



Front-End ASICs for CZT and Si Multi-Element Detectors

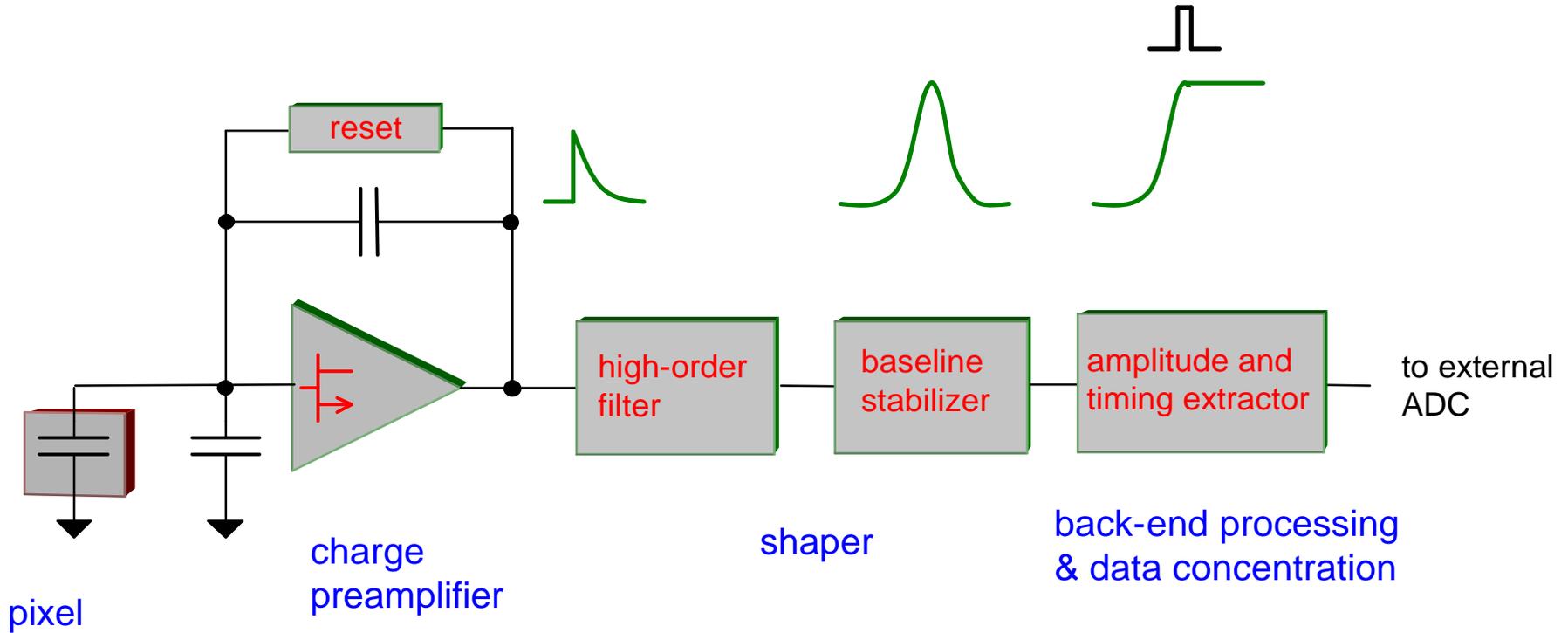
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Outline

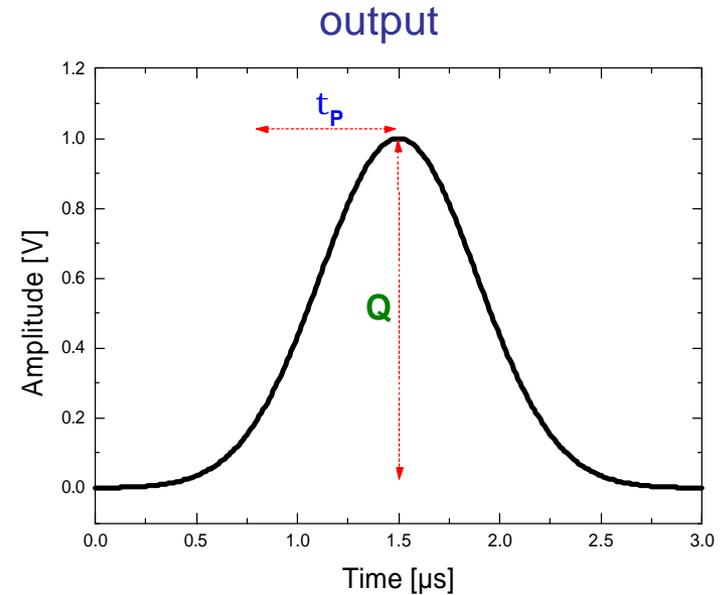
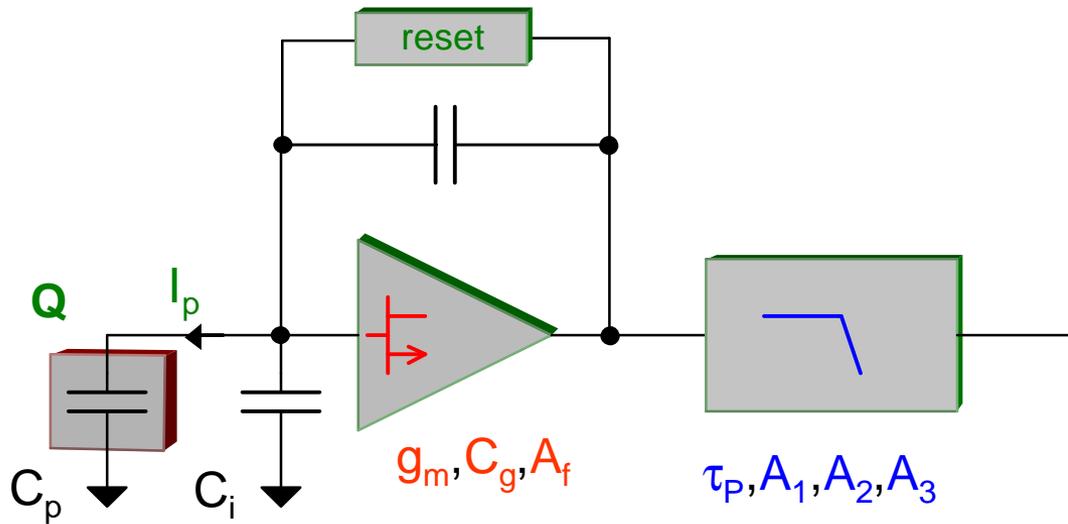
- I. Circuit Solutions
- II. ASICs for CdZnTe Sensors
- III. ASICs for Si Sensors

Typical front-end channel



- high reliability
- ease of use
- spectroscopic quality
- data concentration optimization

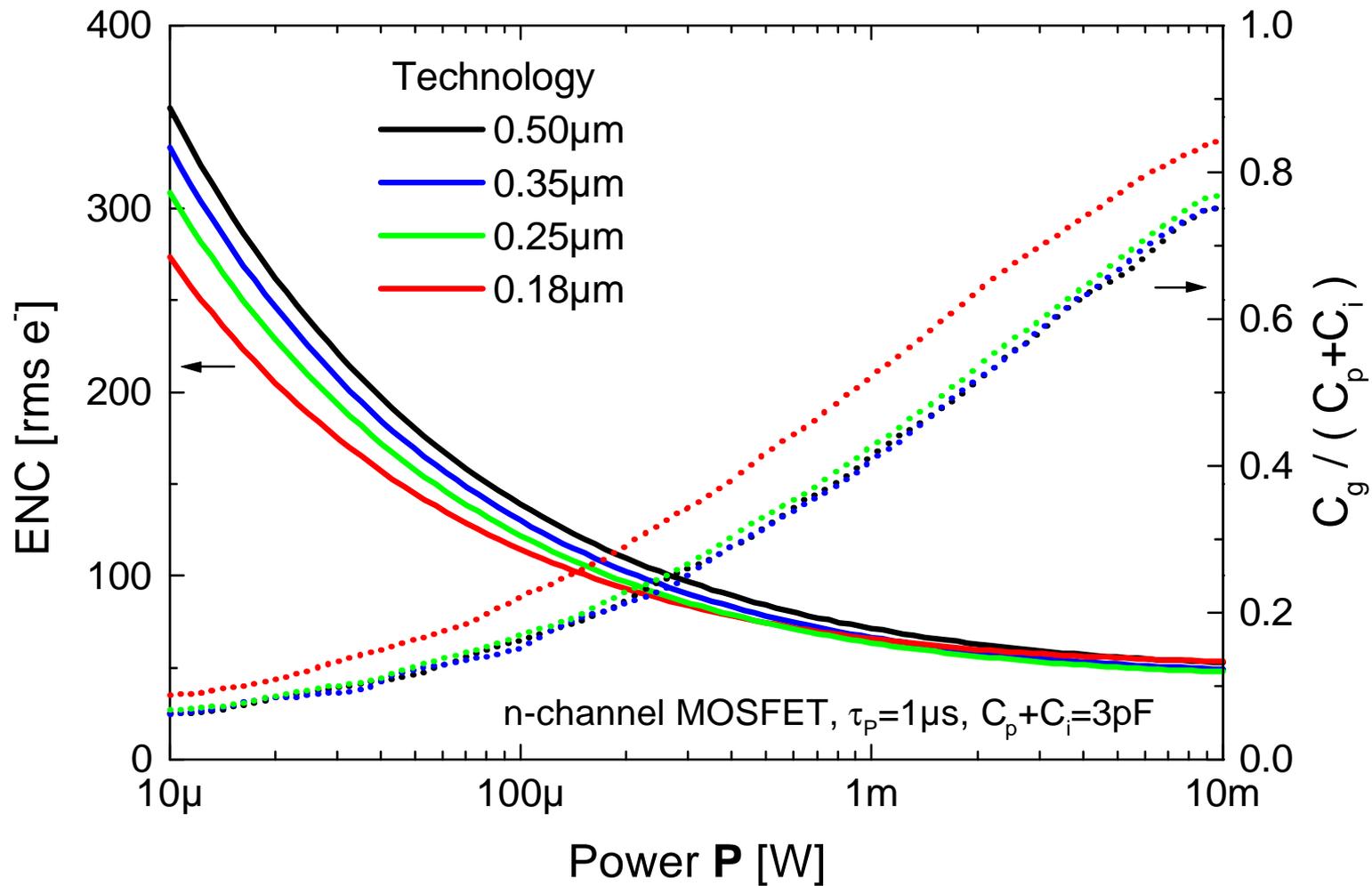
Input MOSFET optimization



$$\text{ENC}^2 = \frac{A_1}{\tau_P} \frac{(C_p + C_i + C_g)^2}{g_m} + A_2 A_f (C_p + C_i + C_g)^2 + A_3 \tau_P (I_p + I_{rst})$$

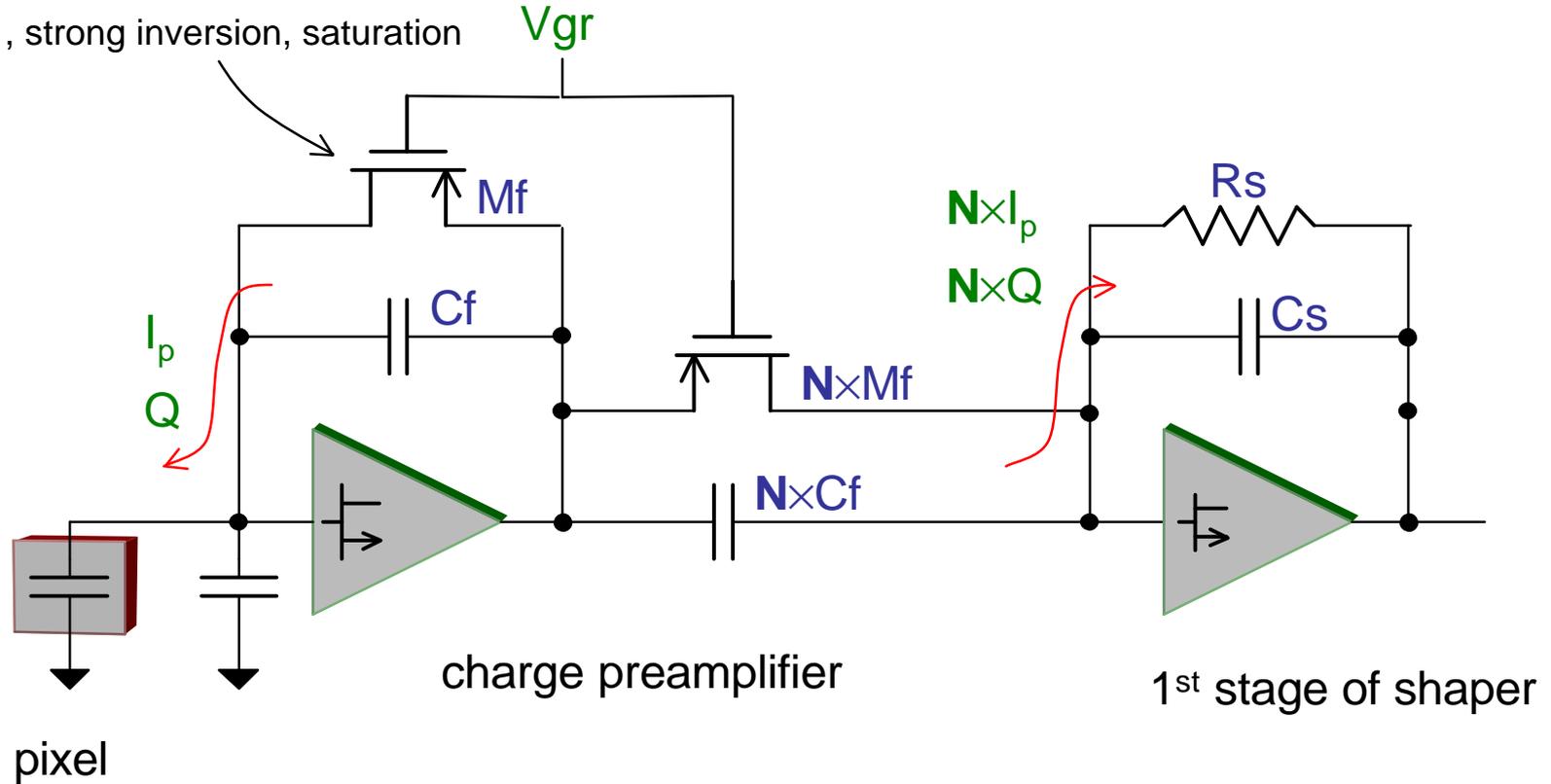
g_m, C_g, A_f , are functions of input MOSFET width \mathbf{W} and power \mathbf{P}

Input MOSFET optimization



Continuous reset of the preamplifier

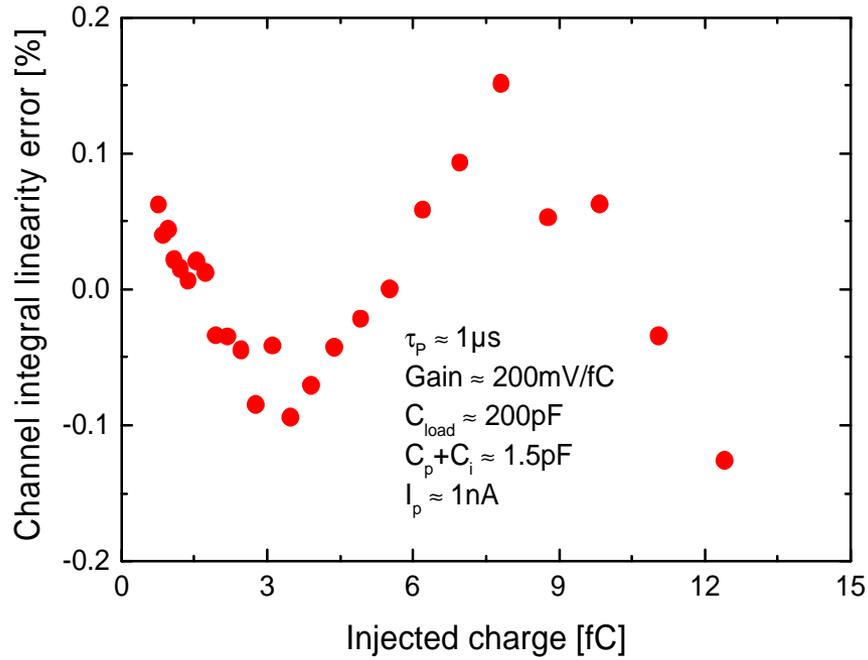
$L/W \gg 1$, strong inversion, saturation



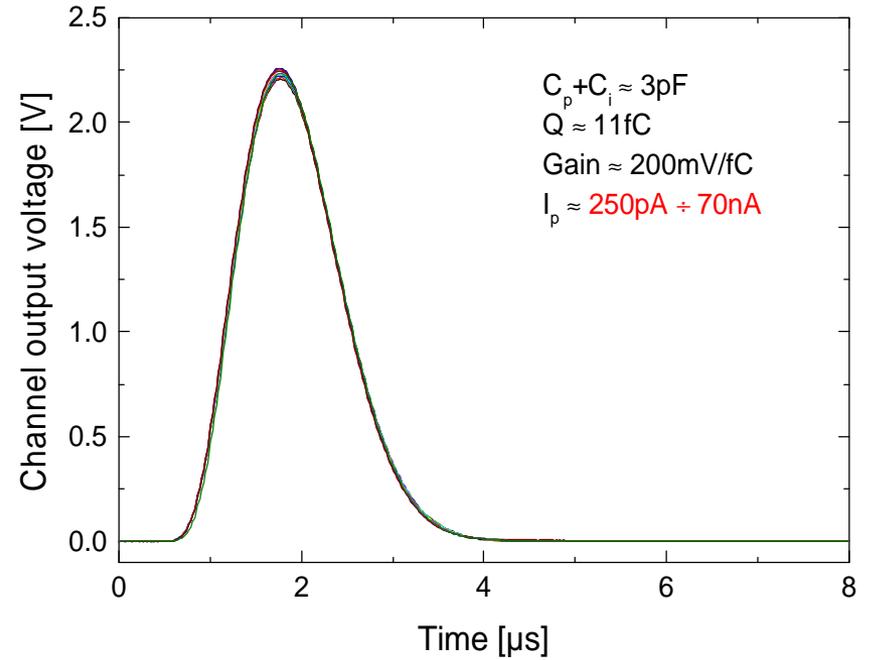
- current gain equal to N
- fully linear
- **self-adapts** to leakage current
- minimum noise contribution

Continuous reset of the preamplifier

linearity



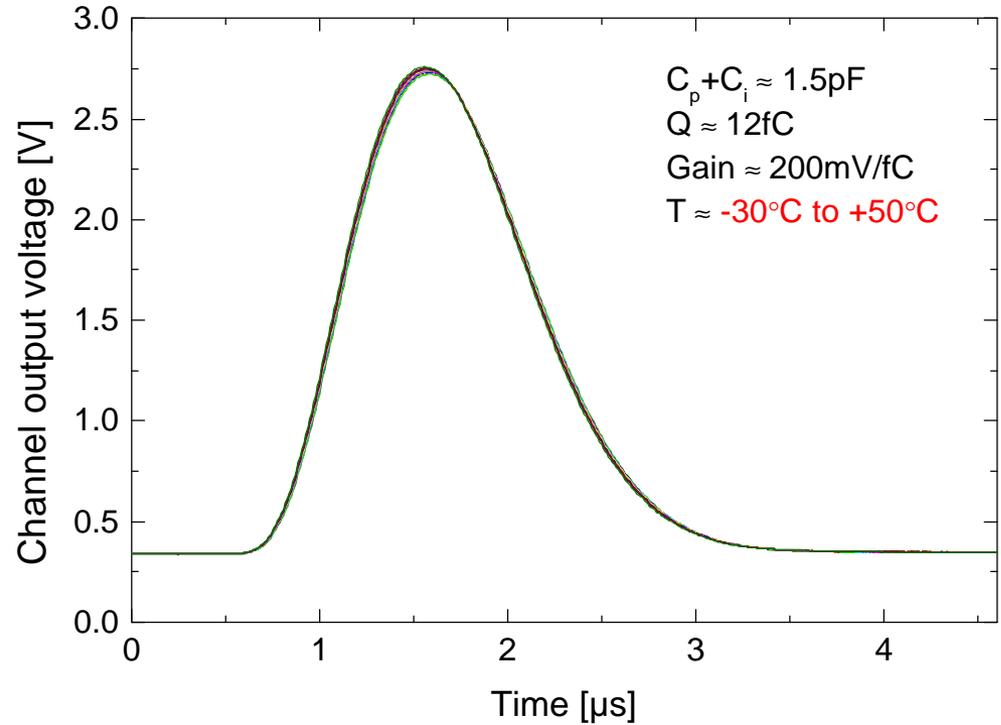
output vs pixel leakage current



First generation of front-end ASICs

other features

- plug & play
- per-channel test capacitor
- programmable gain
- programmable peaking time
- high output drive capability
- high stability vs temperature →





Generation of front-end ASICs for CZT

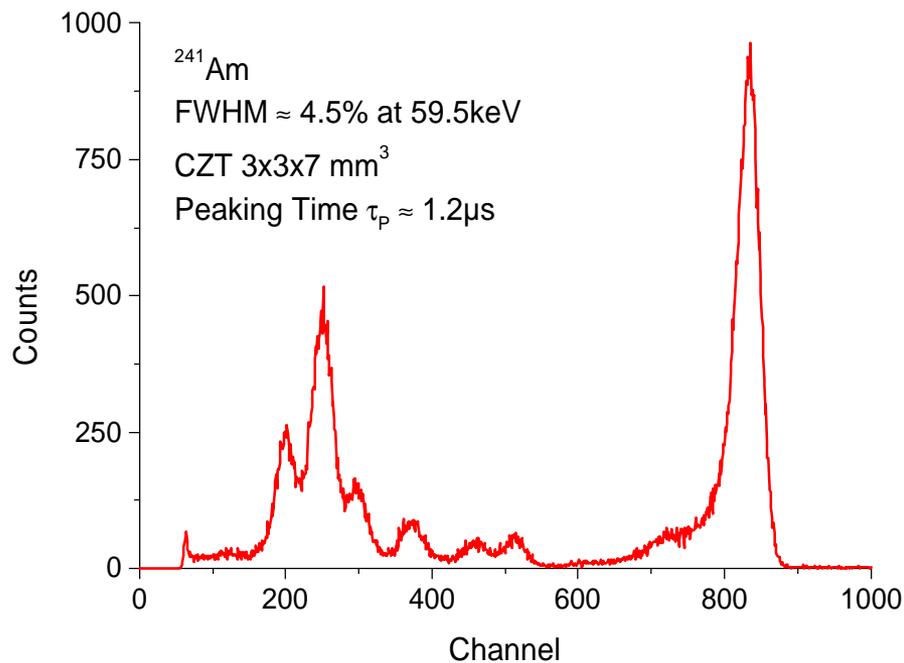


| ASIC | Pixel capacitance [pF] | Channel count | Peaking time [μ s] | Gain [mV/fC] | Power / channel [mW] | ENC [rms. e ⁻] | Applications |
|--------------------|------------------------|---------------|-------------------------|------------------|----------------------|----------------------------|--|
| General purpose | 3 | 16 | 0.6, 1.2, 2.0, 4.0 | 30, 50, 100, 200 | 18 | 30+20/pF | <i>LFOV Gamma Camera SFOV Gamma Camera Nuclear Safeguards</i> |
| Medium speed | 3 | 4 | 0.4 | 200 | 18 | 29+27/pF | <i>Down Hole Well Logging X-Ray Diffraction Gauges</i> |
| High speed bipolar | 3 | 8 | 0.2 | 240 | 18 | 42+44/pF | <i>Bone Densitometry Pulse Mode CT Industrial X-Ray</i> |
| High capacitance | 12 | 8 | 0.6, 1.2, 2.0, 4.0 | 30, 50, 100, 200 | 35 | 57+10/pF | <i>Industrial Strip Detectors Backscatter Gauges Large Area Detector</i> |

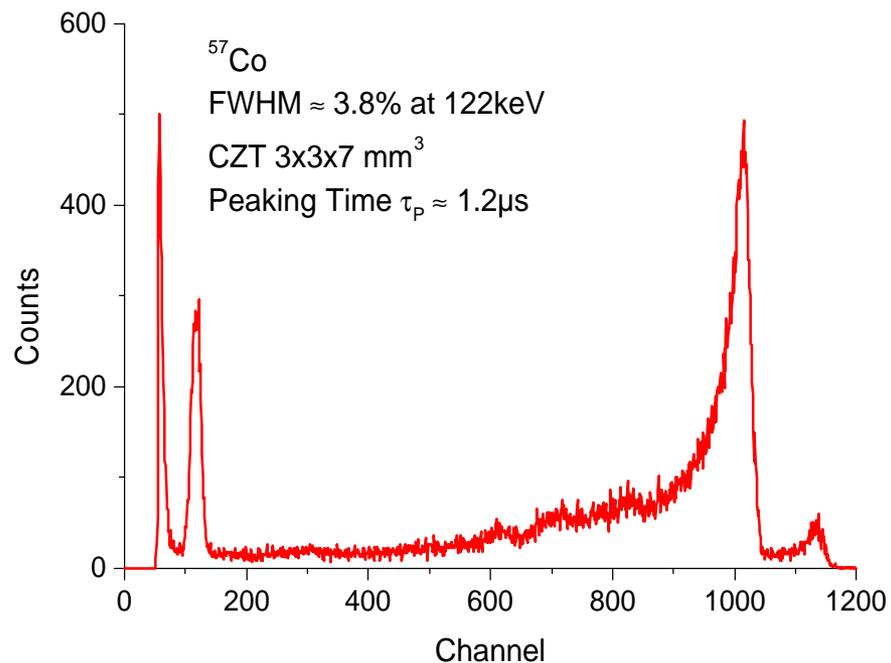
Technology : 0.5 μ m CMOS SP3M

CZT – ASIC spectra measurements

^{241}Am spectrum

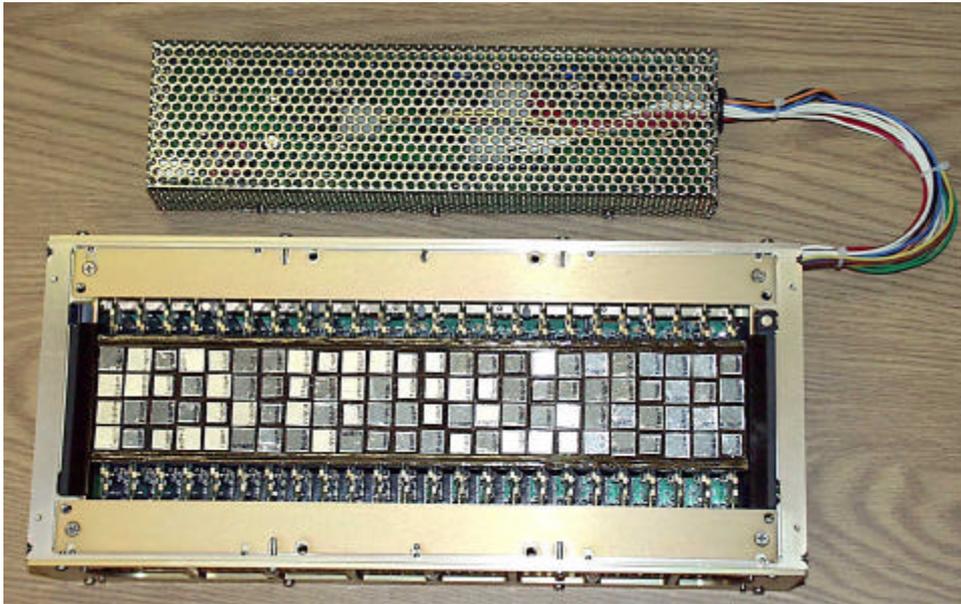


^{57}Co spectrum



CZT – ASIC applications

Solstice Gamma camera



- 96 CZT crystals
- 3072 pixels
- 192 front-end ASICs
- 1.3M events/second
- average FWHM 3.8% at 122keV

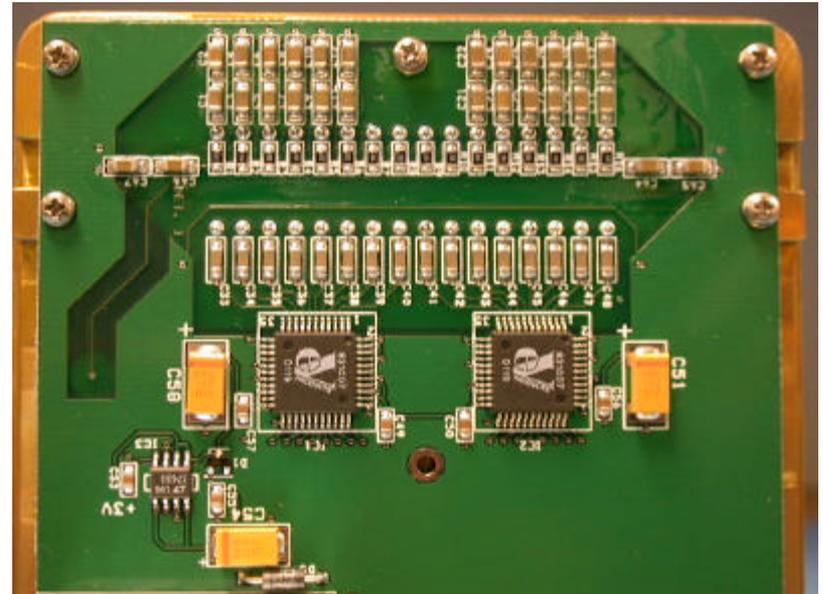
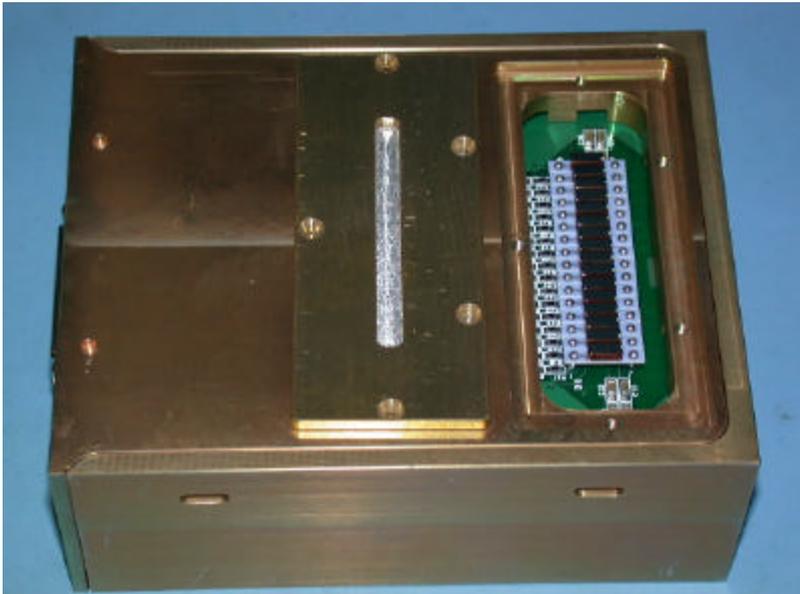
eZ-SCOPE hand held Gamma camera



- 1 CZT crystal
- 256 pixels
- 16 front-end ASICs
- 4.8M events/second
- average FWHM 4.0% at 122keV

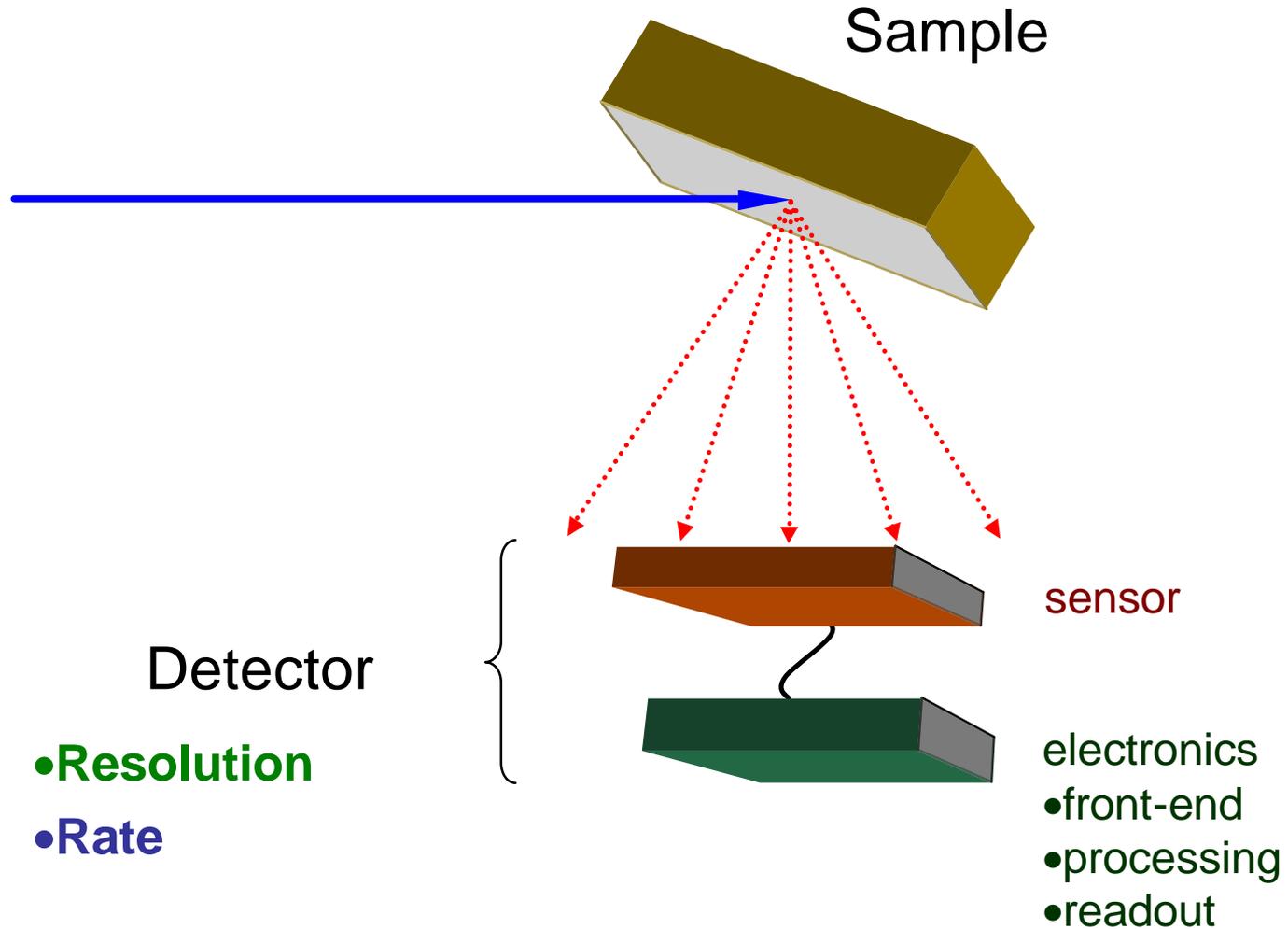
CZT – ASIC applications

Bone Densitometry – GE Lunar Detector

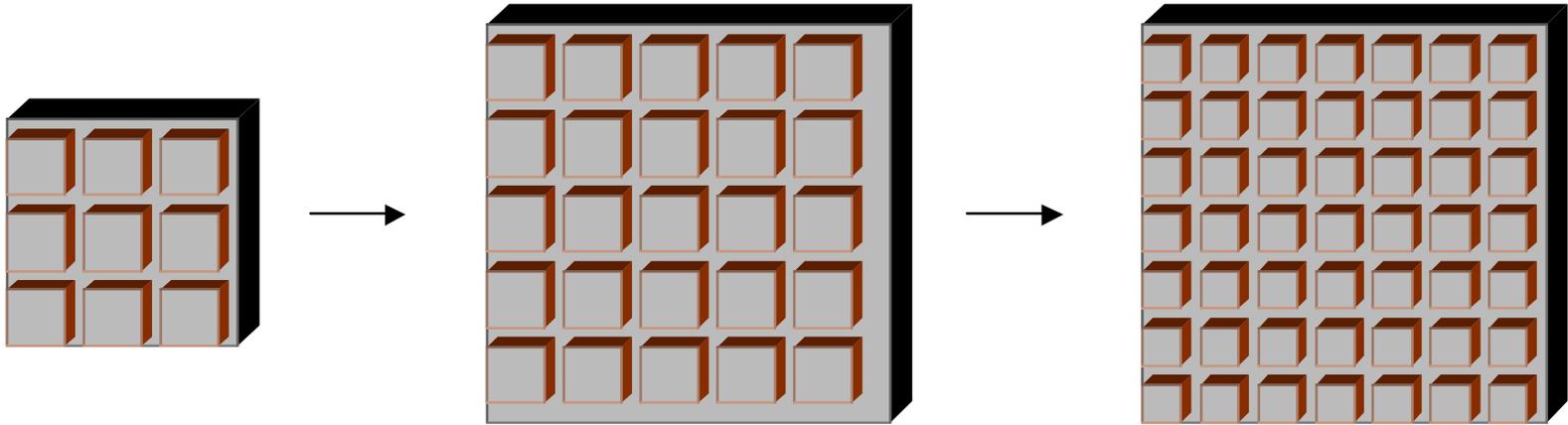


- 16 CZT crystals
- 16 pixels 3 x 7 x 3 mm³
- 2 front-end ASICs
- DEXA (Dual Energy X-ray Absorptiometry)
- ASICs replaced 17 circuit boards (over 500 components) and improved performances

Typical fluorescence EXAFS measurement geometry

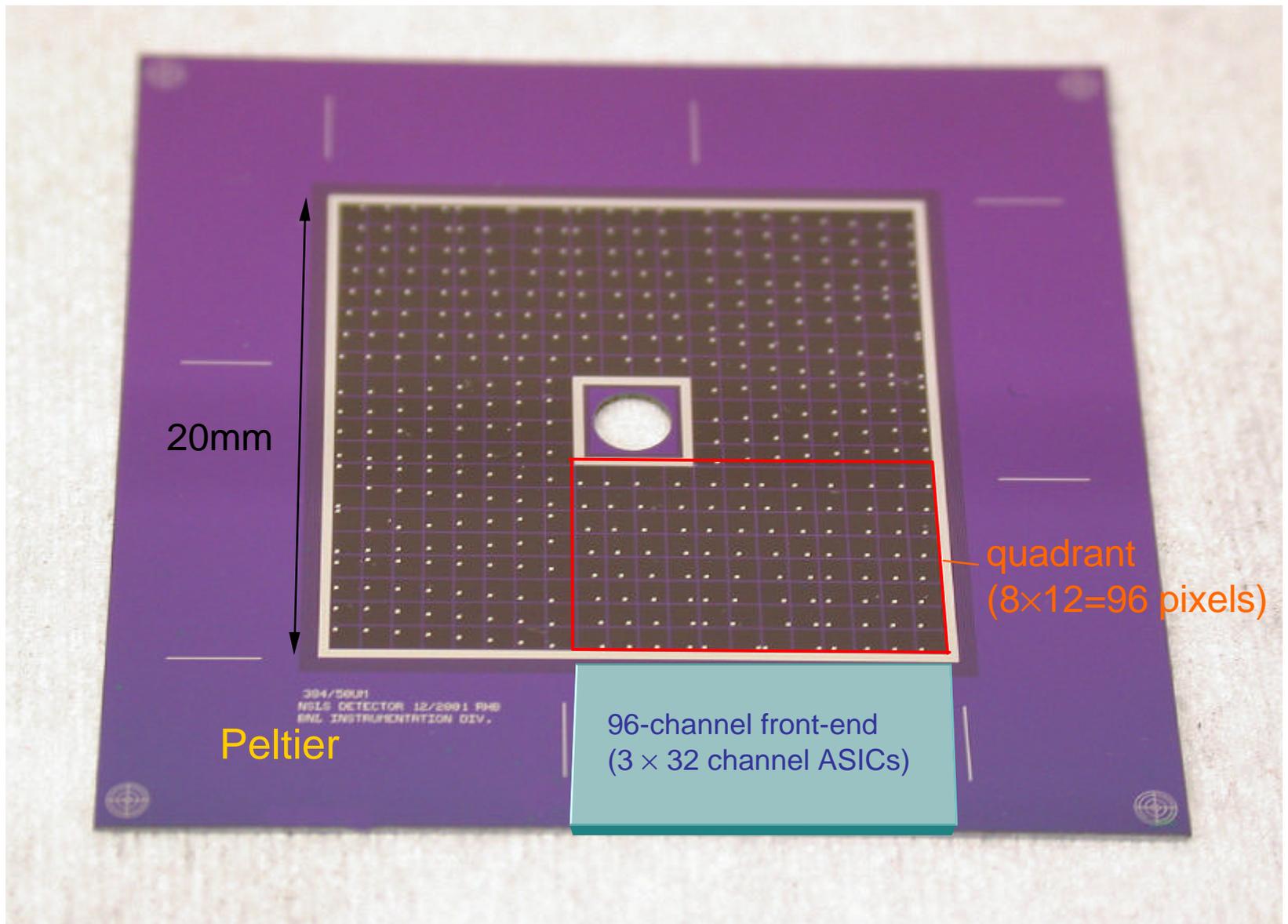


Optimum pixellation



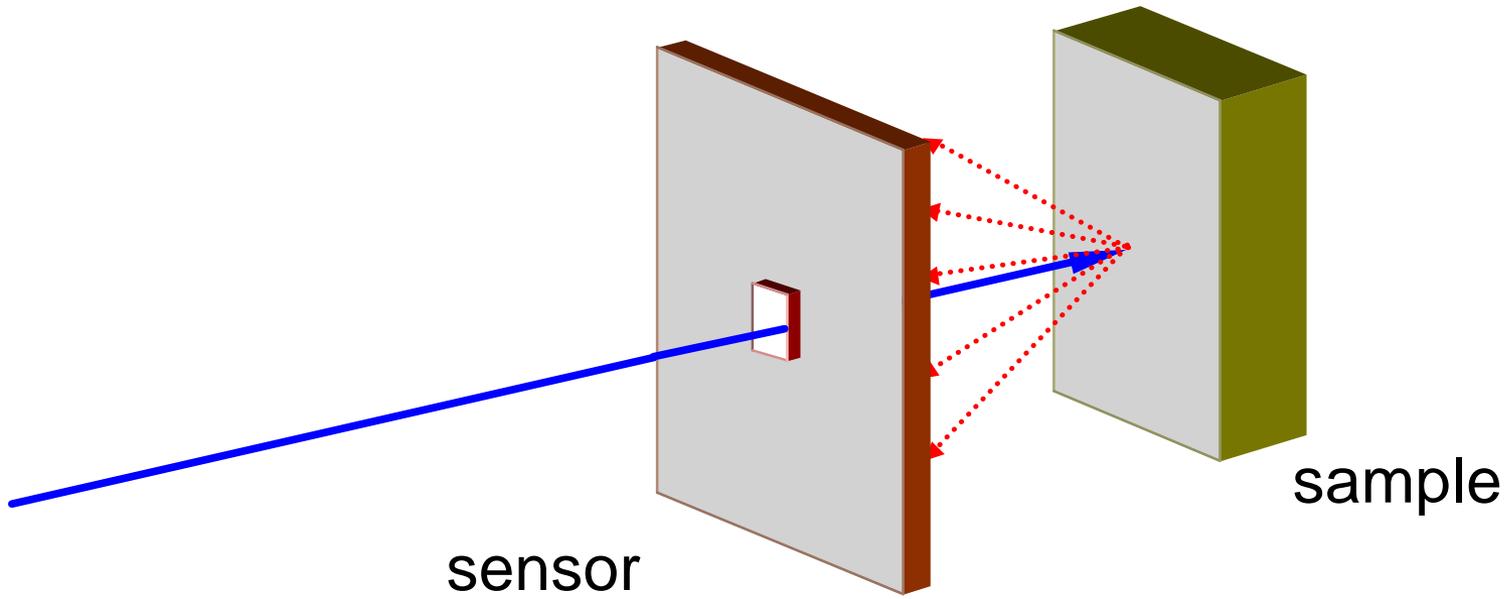
$$\text{ENC} \div \sqrt{\left(C_p(N) + C_i \right)^{\gamma+1} \frac{\text{Rate}}{N} \left(\frac{P}{N} - p_2 \right)^{\gamma}} \quad \gamma = 0.5 \dots 1$$

- charge sharing ($\approx 20\mu\text{m}/\text{side}$) and trapping (gap/side) : empirical

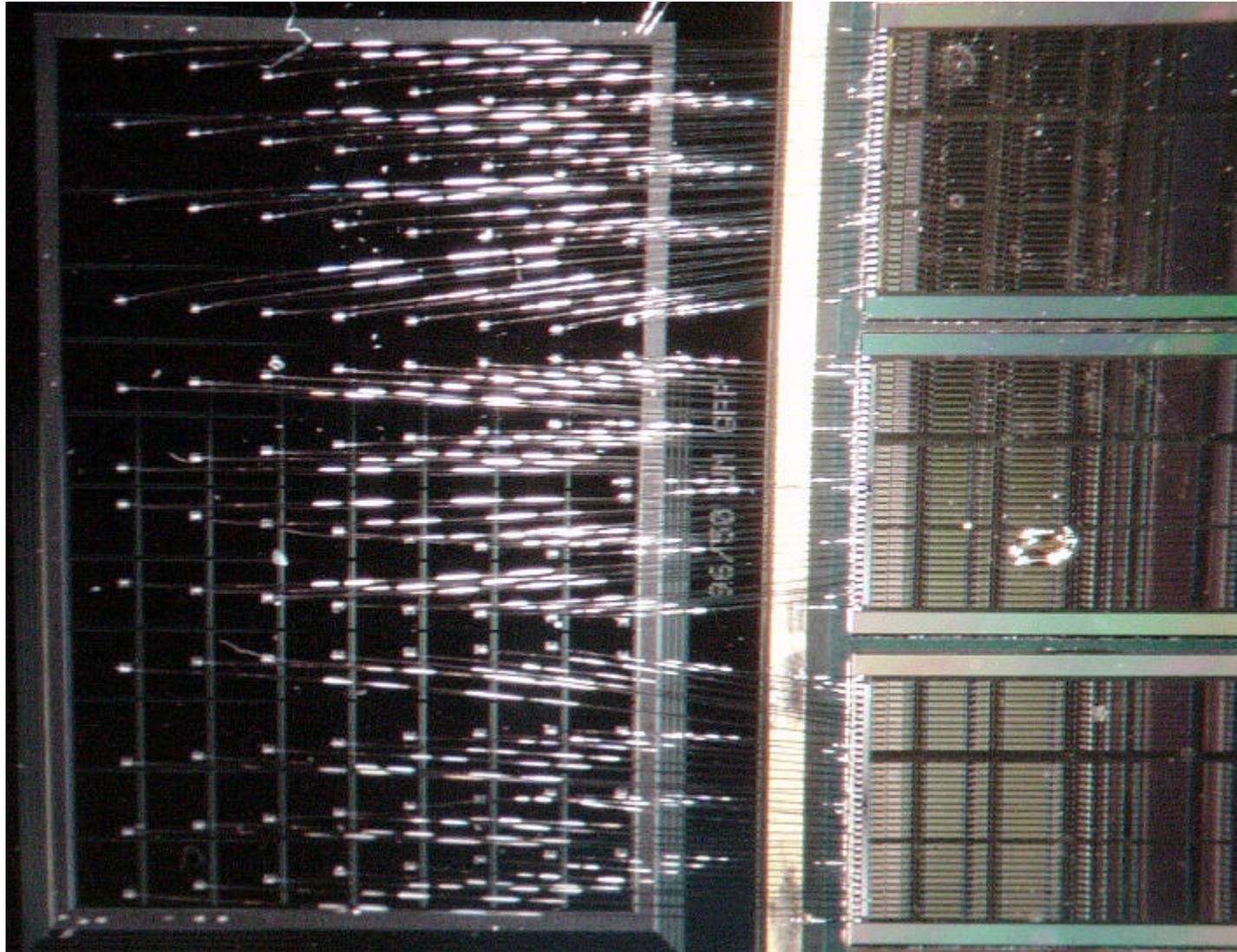


Si n-type high resistivity wafer $250\mu\text{m}$ thick,
 $N = 384$ $p^+ \approx 1\text{mm} \times 1\text{mm}$ pixels,
gaps $10\mu\text{m}$, $30\mu\text{m}$, $50\mu\text{m}$

Beam through

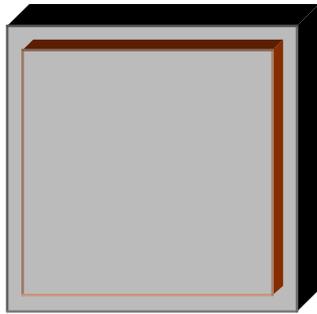


Sensor – ASIC photo

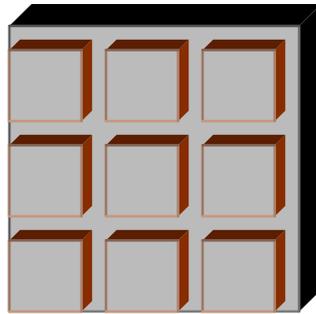


quadrant

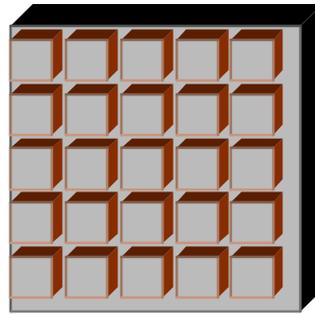
Highly segmented detectors



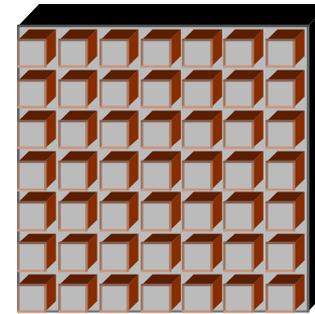
$N=1$



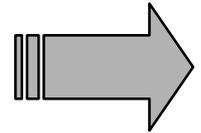
$N=9$



$N=25$



$N=49$



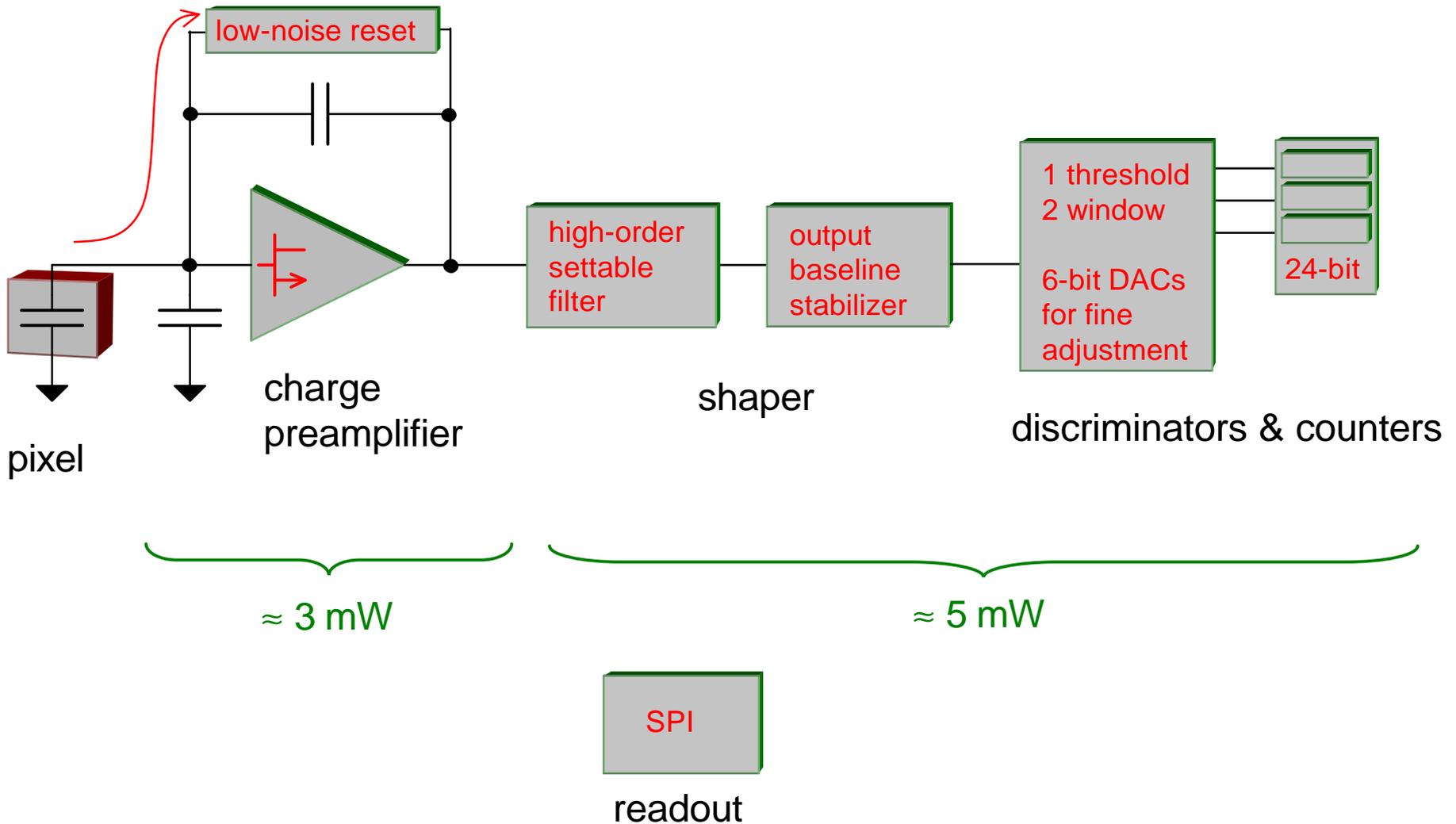
Benefits:

- Position Resolution
 - pixel pitch $\sim 1/\sqrt{N}$
- Energy Resolution:
 - $C_{\text{DET}} \sim 1/N$
 - $I_{\text{DARK}} \sim 1/N$
 - Pulse Shaping time $\sim N$
- Rate capability
 - pileup $\sim 1/N$

Drawbacks:

- Interconnect density
 - density $\sim N$
- Electronics channel count
 - cost $\sim N$
 - power $\sim N$

Front-end channel overview



Technology CMOS 0.35 μm 3.3V 2P4M

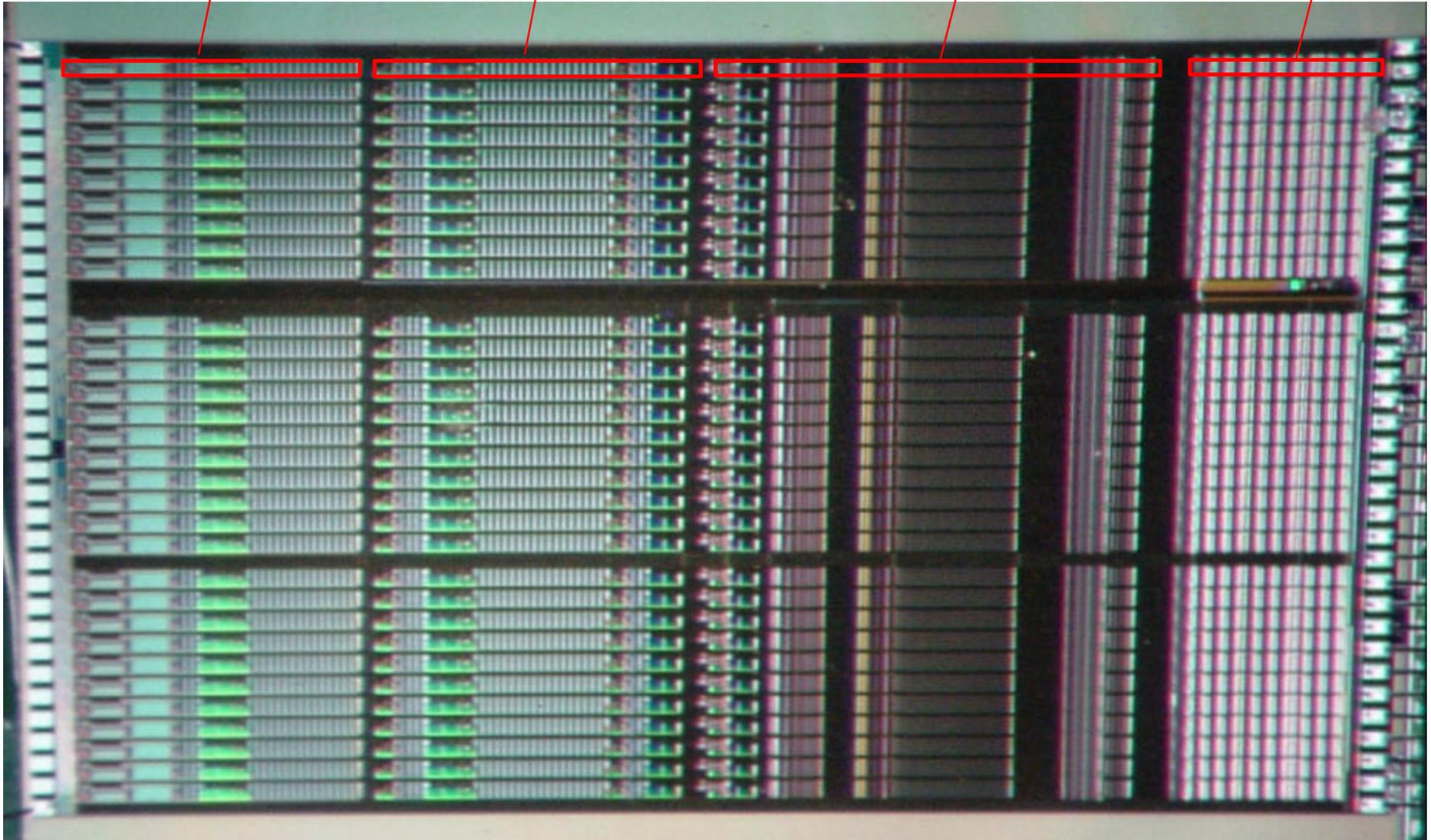
ASIC photo

charge preamplifier

shaper with BLH

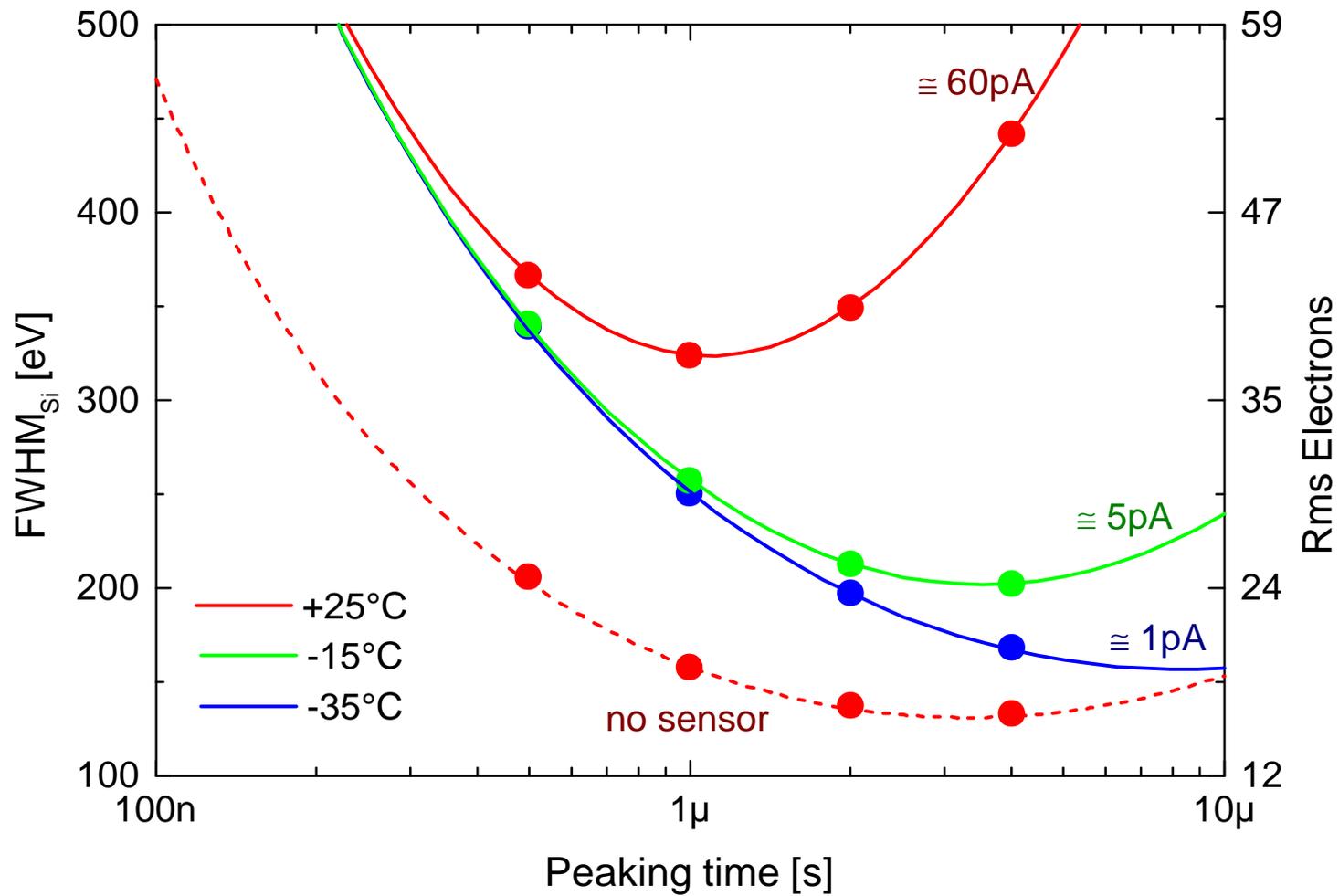
discriminators and DACs

counters

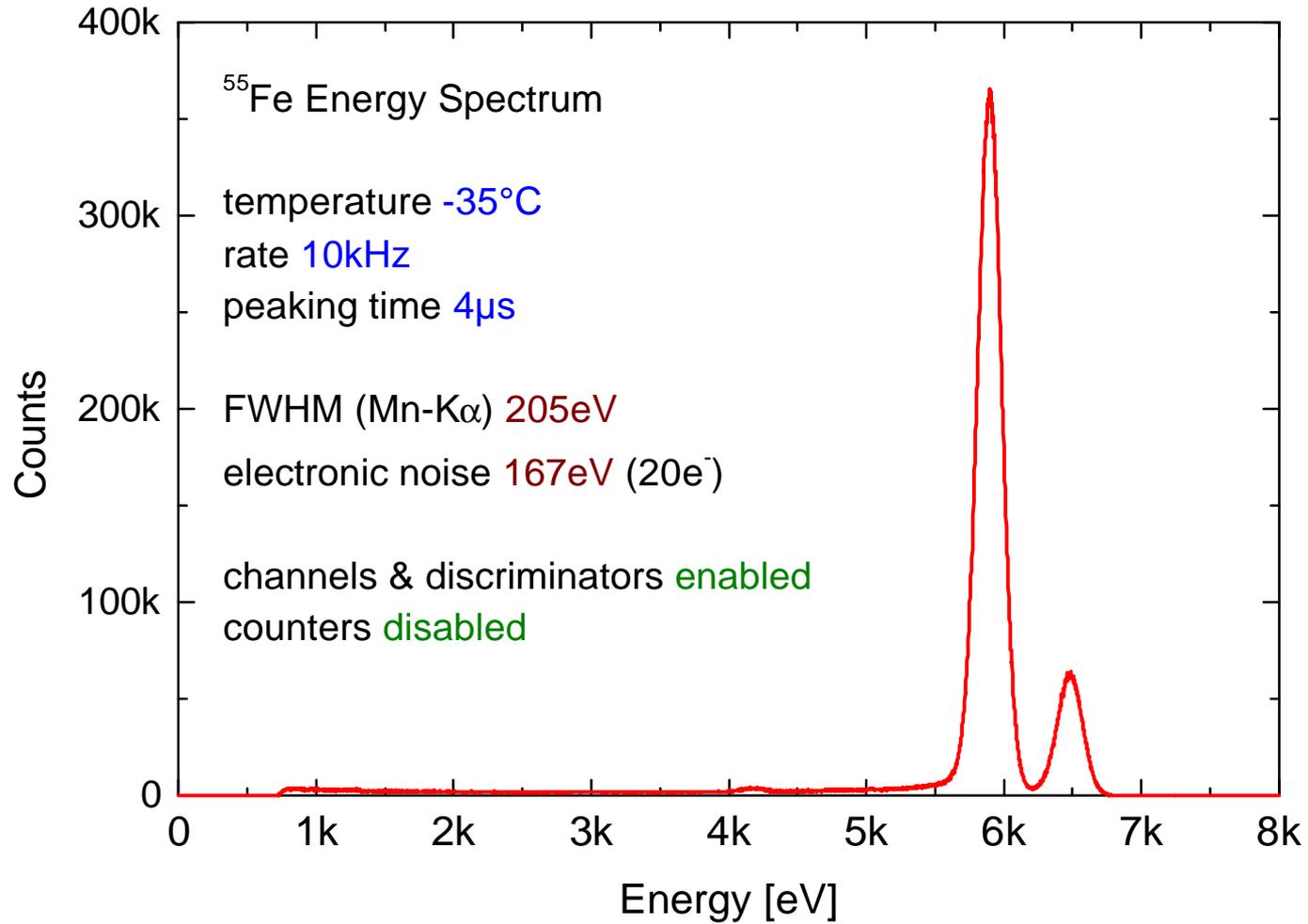


32 channels, 3.6 × 6.3 mm²

Energy resolution



Si – ASIC spectra measurements

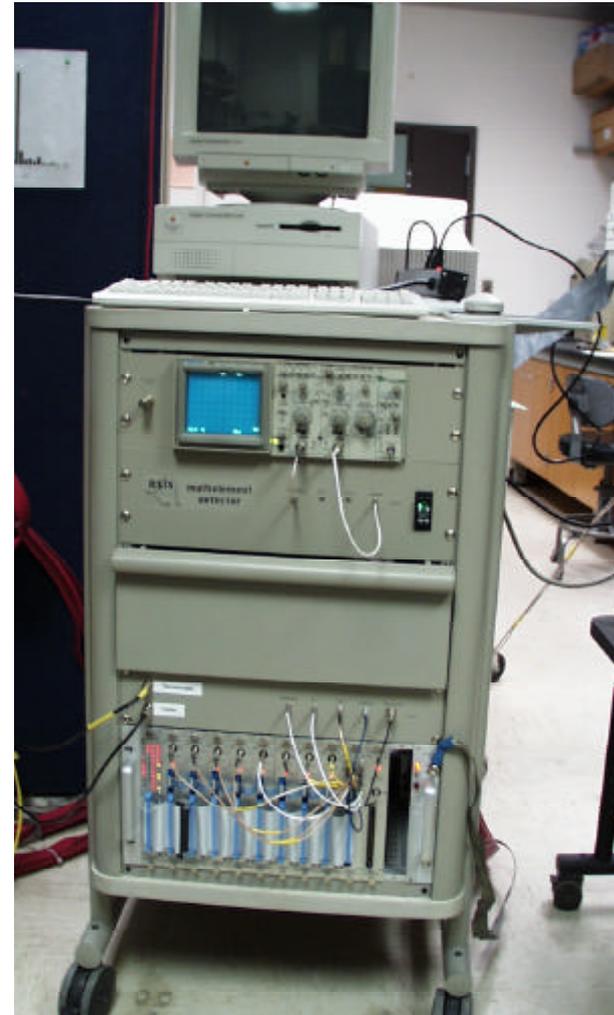


Current EXAFS detector



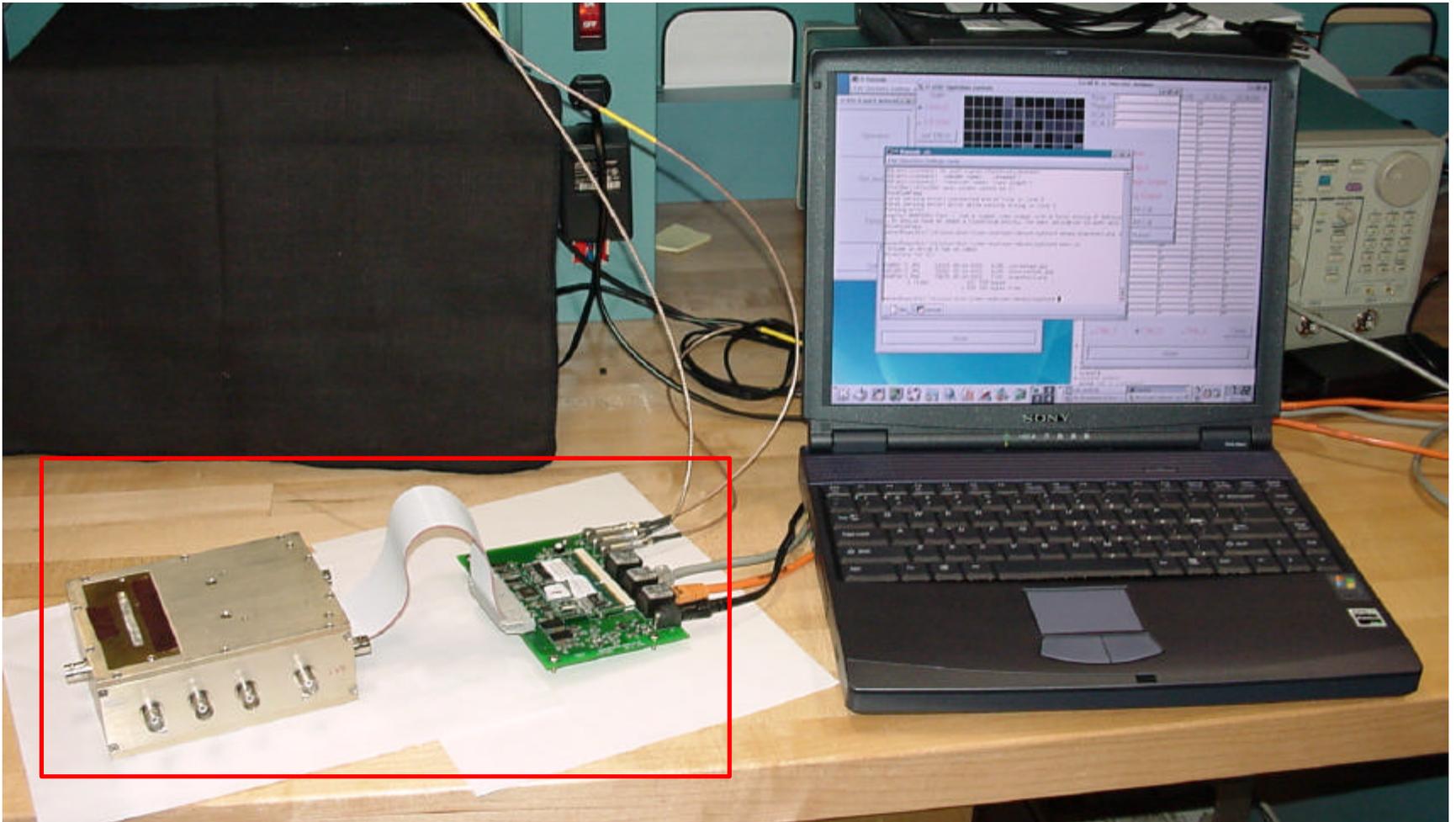
head - *preamplifiers*

» 100 channels, > 350 eV, < 1 MHz



rack - *shapers ...*

New EXAFS detector



» 400 channels, < 300 eV, > 10MHz